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TC 2800 MAIL ROOM

501.36931X00  
Expedited Procedure Requested  
Amendment Under 37 CFR 1.116  
Group 2813

# 22/944  
3/8/02  
2813  
3/28/03  
Munish

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): IWASAKI, et al.  
Serial No.: 09/255,856  
Filed: February 23, 1999  
For: SEMICONDUCTOR DEVICE WITH LAYERED  
INTERCONNECT STRUCTURE  
Group: 2813  
Examiner: S. Smoot

AMENDMENT AFTER FINAL REJECTION

Assistant Commissioner for Patents  
**Box AF**  
Washington, D.C. 20231

March 4, 2002

Sir:

In response to the Office Action mailed December 3, 2001, please amend  
the above-identified application as follows:

IN THE CLAIMS

Please amend the claims presently in the application as follows:

O.K. to  
Enter  
S.W.S.  
3-11-2002